



Docket No.: 42P13639D

JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Andrew J. Kuzma

Application No.: 10/659,898

Filed: September 11, 2003

For: WAFER-LEVEL TEST STRUCTURE
FOR EDGE-EMITTING
SEMICONDUCTOR LASERS

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) Examiner: Jennifer M. Dolan
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) Art Unit: 2813
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Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF REPLACEMENT DRAWINGS

Sir:

Submitted herewith are replacement drawings, Figures 1-9 (6 sheets). No new matter has been added. Applicants respectfully request approval of the enclosed replacement drawings for the above-identified application.

Respectfully submitted,

BLAKELY SOKOLOFF TAYLOR & ZAFMAN, LLP

Date: 6-20-06

Todd M. Becker
Todd M. Becker
Reg. No. 43,487

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on June 20, 2006
Date of Deposit

Yuko Tanaka
Name of Person Mailing Correspondence

Y. Tanaka
Signature

6-20-06
Date